

Micro-Pulling Down-Grown Nd³⁺: (La_{1-x}, Ba_x)F_{3-x} as New Vacuum Ultraviolet Scintillator and Potential Laser Material

Marilou M. Cadatal^{1,2}, Y. Furukawa, Young-Seok Seo³, Toshihiro Tatsumi³, Minh Hong Pham^{1,2}, Carlito Ponseca Jr.^{1,2}, Shingo Ono⁴, Elmer Estacio³, Yusuke Furukawa³, Hidetoshi Murakami³, Yasushi Fujimoto³, Nobuhiko Sarukura¹⁻³, Masahiro Nakatsuka³, Kentaro Fukuda⁵, Rayko Simura⁵, Toshihisa Suyama⁶, Akira Yoshikawa⁵

Institute for Molecular Science (IMS)¹

The Graduate University for Advanced Studies²

Institute of Laser Engineering Osaka University³

Opto-electronics Laboratory Nagoya Institute of Technology⁴

Institute of Multidisciplinary Research for Advanced Materials, Tohoku University⁵

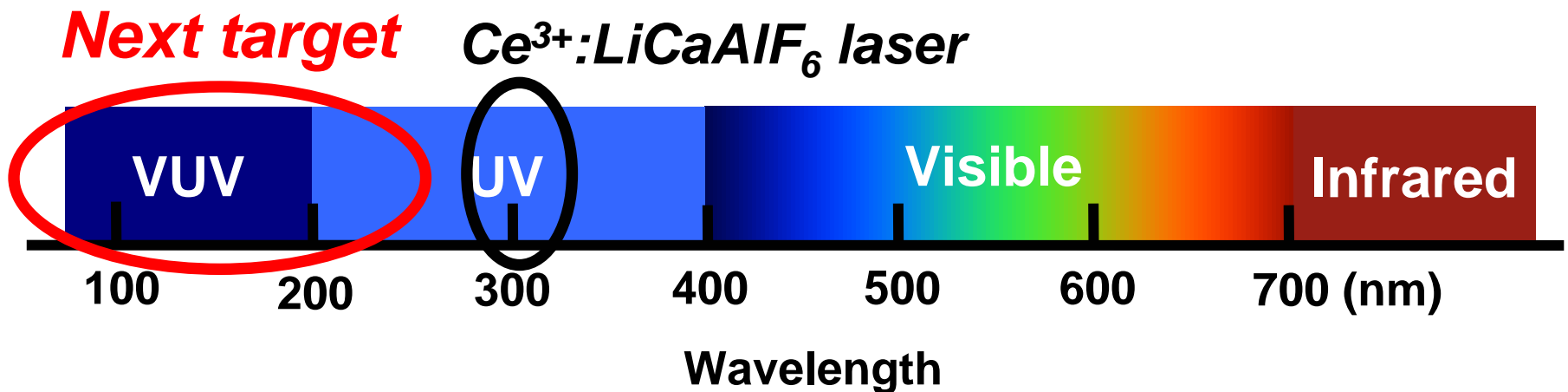
Tokuyama Corporation⁶

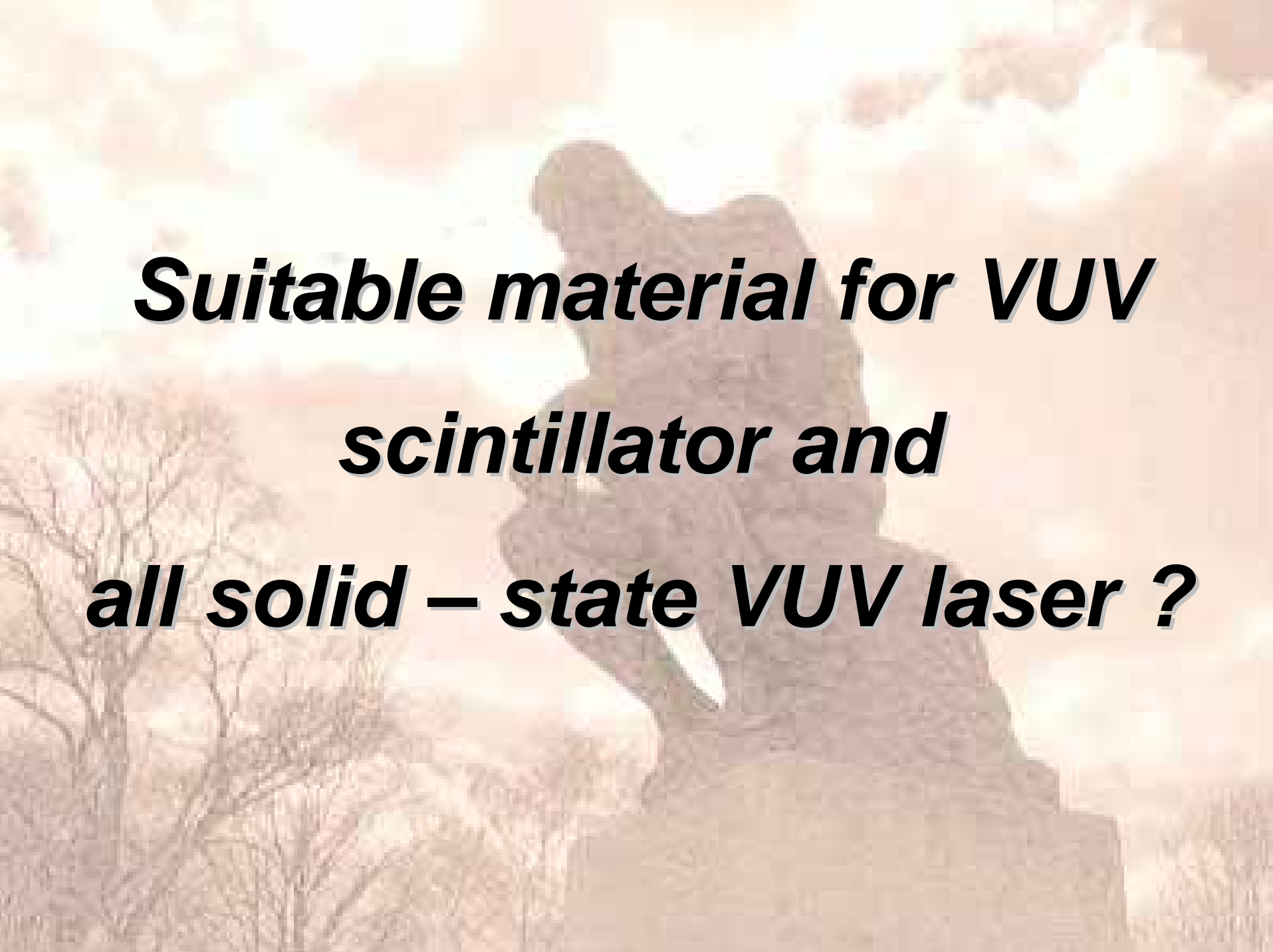
Next target: Shorter wavelength region

**Deep ultraviolet (DUV) region
(250-180 nm)**

and

**Vacuum ultraviolet (VUV) region
(180 nm – 50 nm)**





***Suitable material for VUV
scintillator and
all solid – state VUV laser ?***

Nd³⁺:LaF₃ Emission in the VUV

• Optical pumping

Efficient LaF₃:Nd³⁺-based vacuum-ultraviolet laser at 172 nm

M. A. Dubinskii,* A. C. Cefalas, E. Sarantopoulou, S. M. Spyrou, and C. A. Nicolaides

*Theoretical and Physical Chemistry Institute, National Hellenic Research Foundation,
48 Vassileos Constantinou Avenue, Athens 116-35, Greece*

R. Yu. Abdulsabirov, S. L. Korableva, and V. V. Semashko

Kazan State University, 18 Lenin Street, 420008 Kazan, Russia

Received June 18, 1991

Vacuum-ultraviolet (VUV) laser radiation at 172 nm has been obtained from a solid-state LaF₃:Nd³⁺-based laser pumped by a pulsed-discharge molecular F₂ laser at 157 nm. The maximum slope efficiency of the solid-state laser described in this experiment was 21% (14% conversion efficiency), and the maximum output energy at 172 nm was 0.4 mJ for a nonoptimized optical cavity. This finding introduces serious prospects for realizing versions of active-medium-plus-source tunable VUV laser devices.

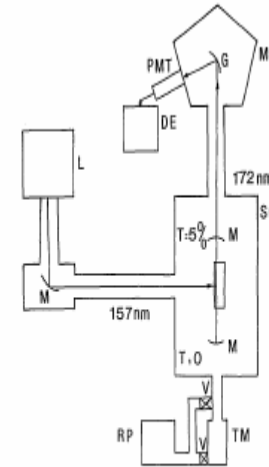


Fig. 2. Experimental layout. L, pulsed-discharge F₂ molecular laser at 157 nm; M's, mirrors; SC, stainless-steel vacuum chamber; MO, monochromator; G, grating; PMT, photomultiplier; DE, detection electronics; TM, turbo molecular pump; RP, rotary pump; V's, valves.

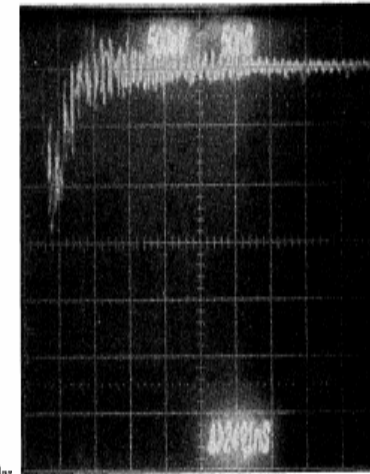


Fig. 4. Temporal evolution of the laser pulse from the LaF₃:Nd³⁺ crystal at 172 nm.

JOSA B 9, 1148 (1992)

• Electron beam pumping

Vacuum ultraviolet laser emission from Nd³⁺:LaF₃

Ronald W. Waynant and Philipp H. Klein
Naval Research Laboratory, Washington, D.C. 20375

(Received 17 August 1984; accepted for publication 18 October 1984)

Laser emission at 172 nm has been produced by pumping a Nd:LaF₃ crystal with incoherent Kr²⁺ radiation at 146 nm. The 5-ns pulse contained approximately 20–30 μJ of energy. Fluorescence measurements indicate potential for tuning from 170–175 nm, which should be observable with OH⁻-free crystals.

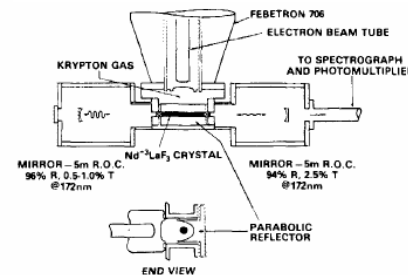


FIG. 1. Excitation system for rapid pumping of Nd³⁺:LaF₃.

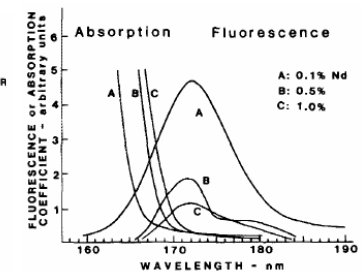


FIG. 3. Absorption spectra of Nd³⁺:LaF₃ samples, superimposed on the fluorescence spectra of Fig. 2.

App. Phys. Lett. 46, 14 (1985)

Nd³⁺:LaF₃ Emission in the VUV

- **Restricted tunability (170 – 175 nm)**
- **Electron beam pumping**
- **All-solid-state VUV laser needed**

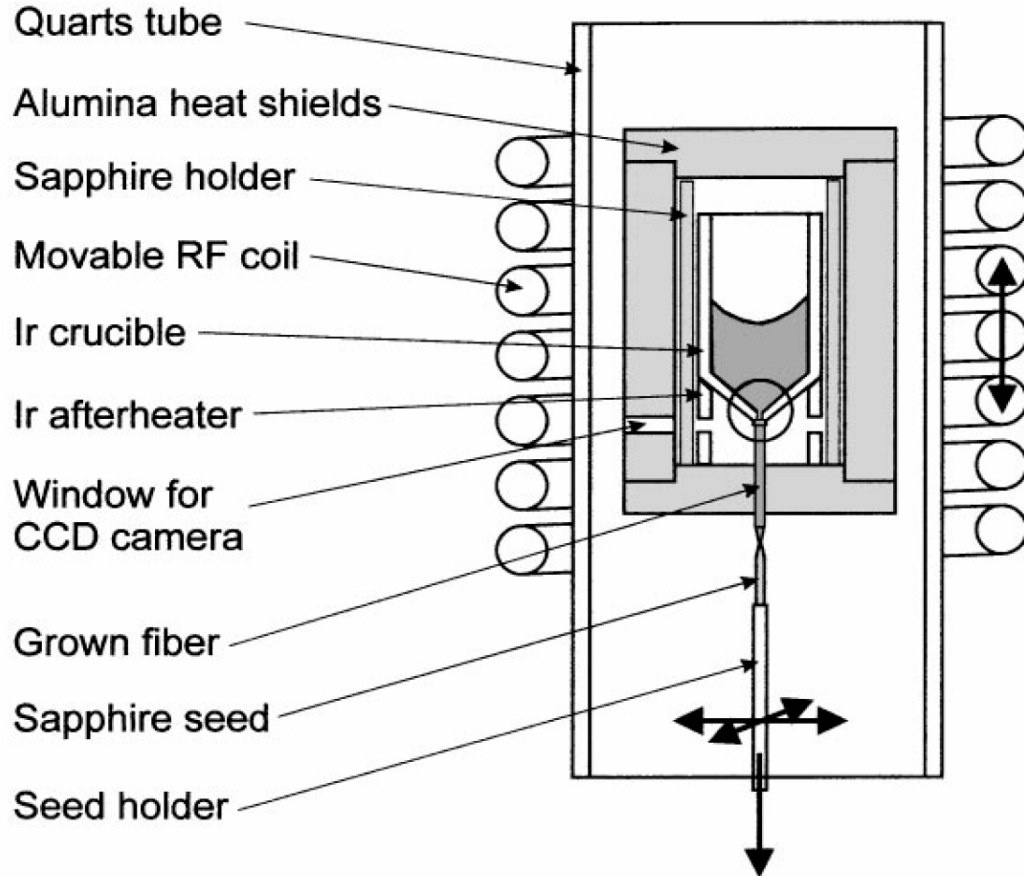
**Looks attractive but not so much
follow-up work**

Purpose

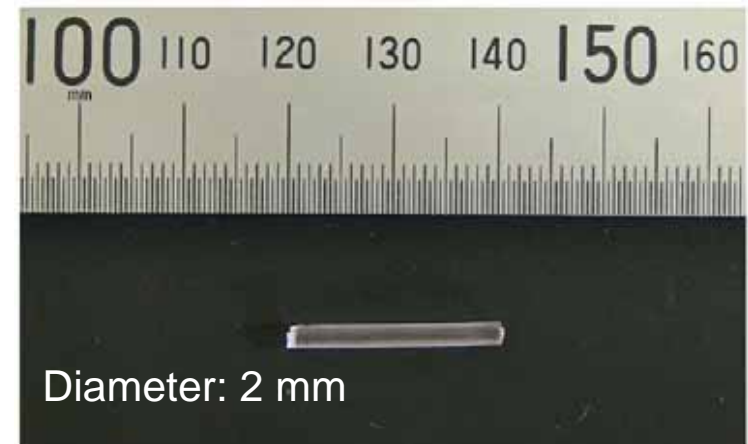
***“Investigate
Nd³⁺: (La_{1-x}Ba_x)F_{3-x} (x=0.1) grown by
Micro – PD method as new VUV
scintillator and potential laser
material”***

Growth of $\text{Nd}^{3+}:\text{La}_{(1-x)}\text{Ba}_x\text{F}_{(3-x)}$ ($x=0.1$) by Micro-Pulling Down Method

Micro-PD apparatus for fluoride crystal growth

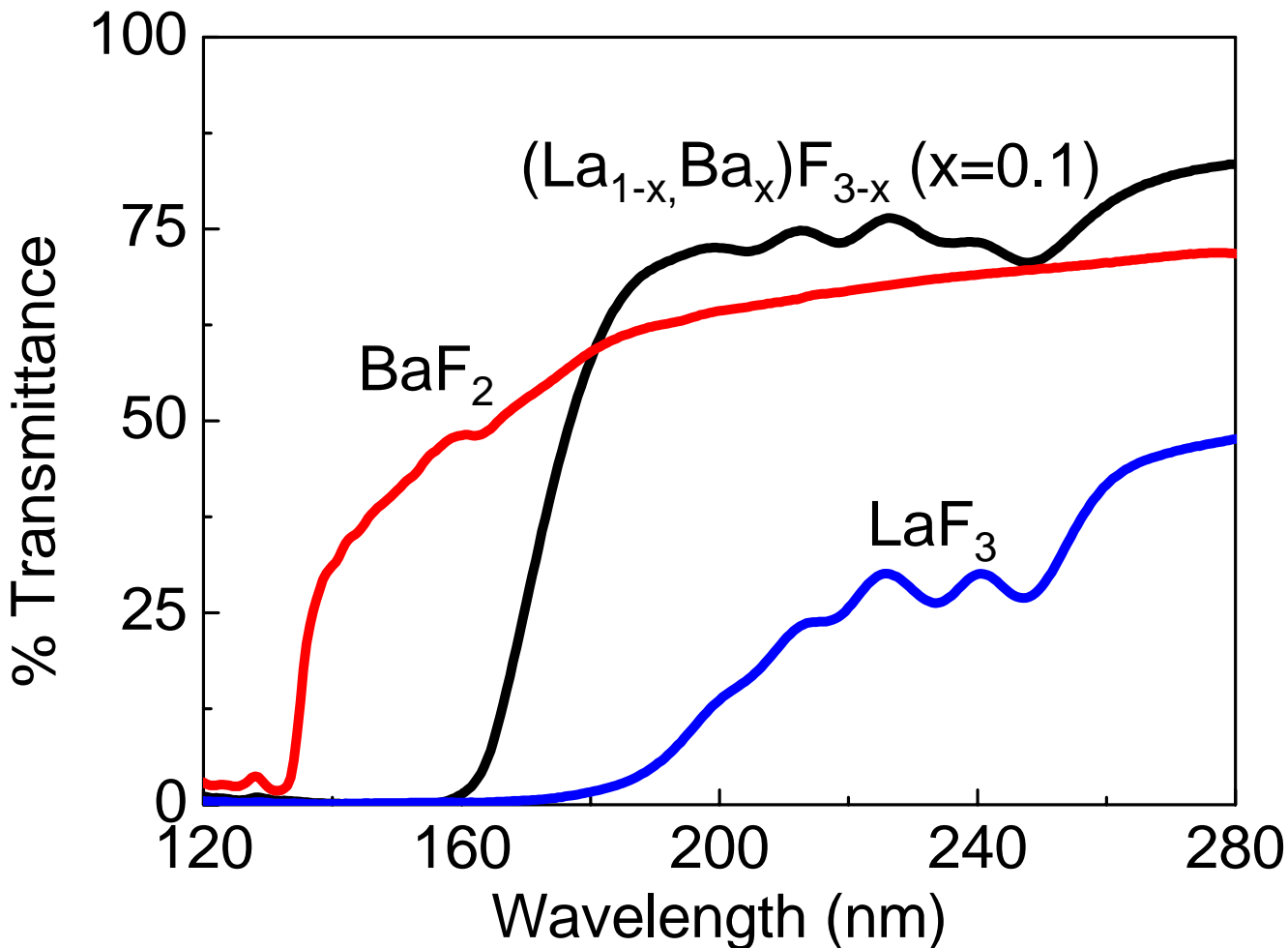


$\text{Nd}^{3+}:\text{La}_{(1-x)}\text{Ba}_x\text{F}_{(3-x)}$ ($x=0.1$)
sample by Prof. Fukuda at
Tohoku University



A. Yoshikawa, T. Satonaga, K. Kamada, H. Sato, M. Nikl, N. Solovieva, T. Fukuda, *J. Cryst. Growth* **270**, 427 (2004)

Transmission Characteristics of $\text{La}_{(1-x)}\text{Ba}_x\text{F}_{(3-x)}$ ($x=0.1$) and LaF_3



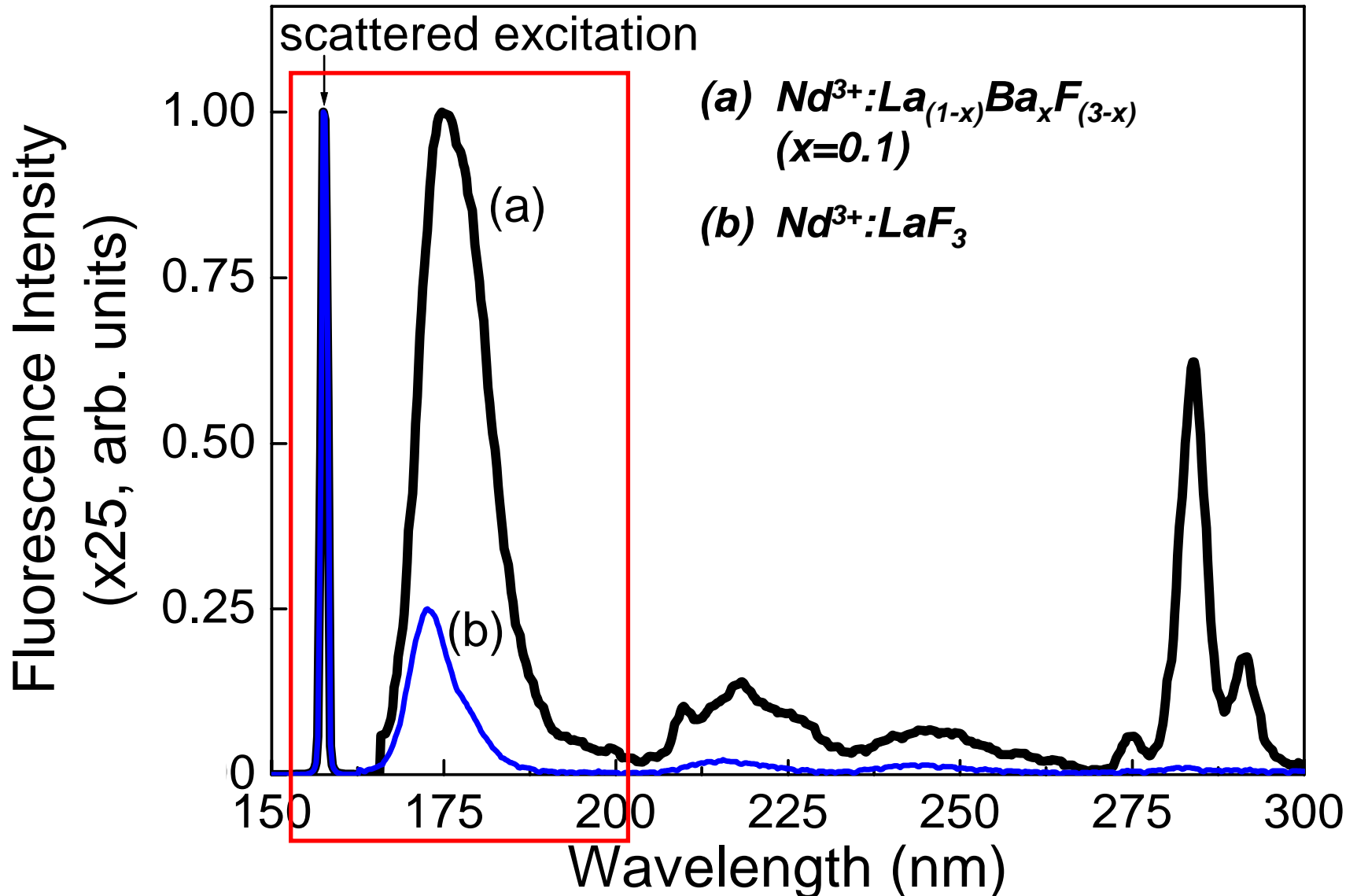
Transmission Edges:

BaF₂ : 134 nm

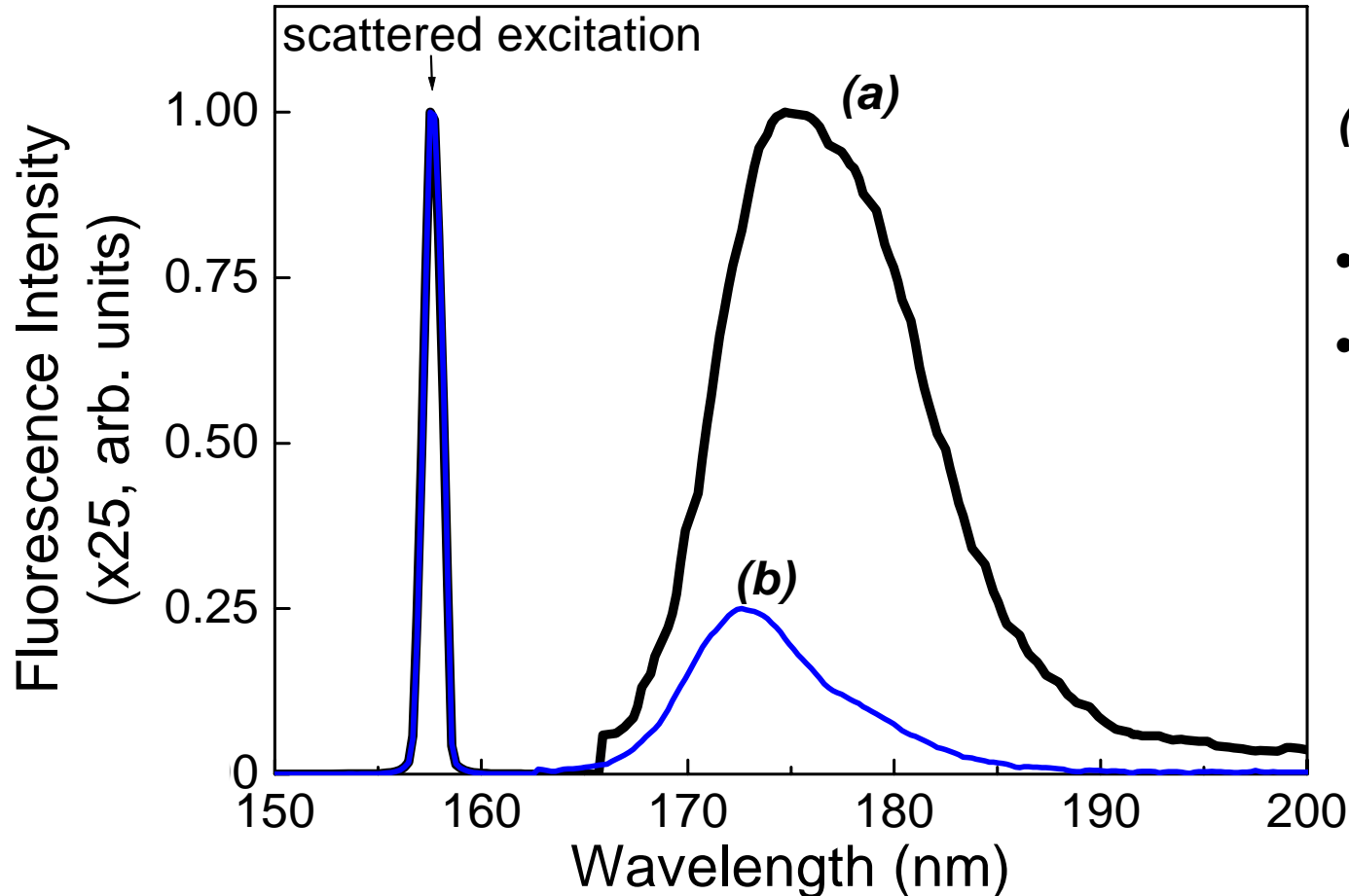
(La_{1-x}, Ba_x)F_{3-x} : 160 nm

LaF₃ : 180 nm

Fluorescence spectra of $Nd^{3+}:La_{(1-x)}Ba_xF_{(3-x)}$ ($x=0.1$) and $Nd^{3+}:LaF_3$



VUV Fluorescence spectra of $\text{Nd}^{3+}:\text{La}_{(1-x)}\text{Ba}_x\text{F}_{(3-x)}$ ($x=0.1$) and $\text{Nd}^{3+}:\text{LaF}_3$



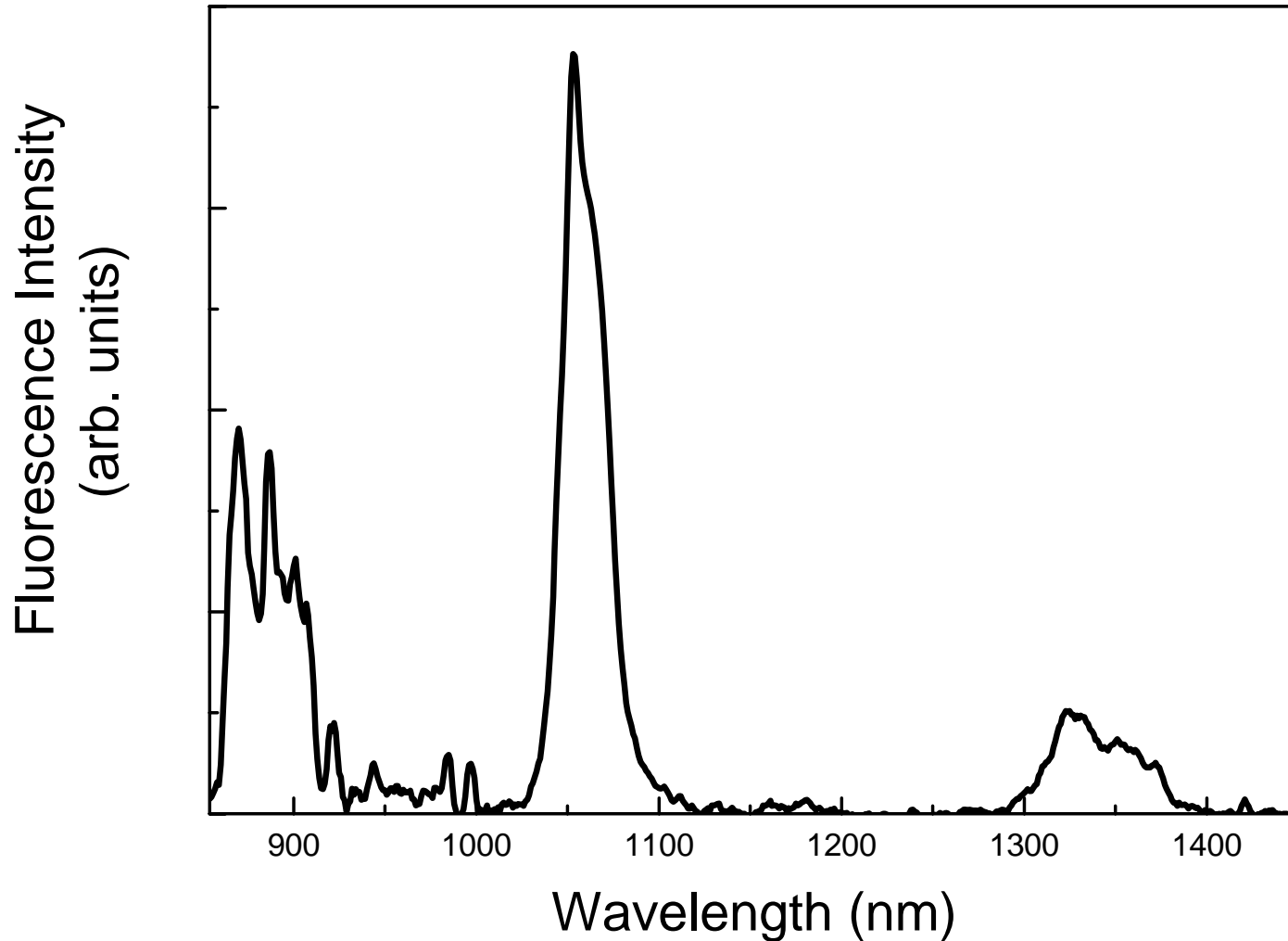
(a) $\text{Nd}^{3+}:\text{La}_{(1-x)}\text{Ba}_x\text{F}_{(3-x)}$
($x=0.1$)

- Peak: 175 nm
- FWHM: 12 nm

(b) $\text{Nd}^{3+}:\text{LaF}_3$

- Peak: 172 nm
- FWHM: 8 nm

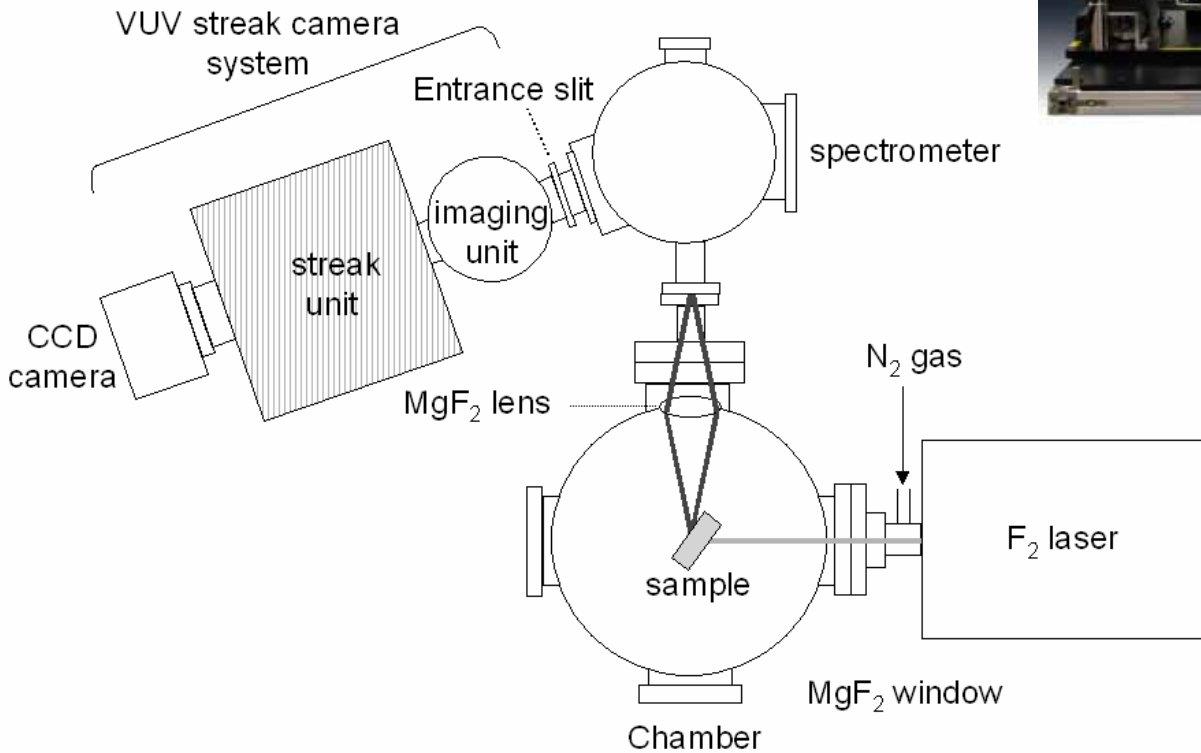
IR Fluorescence spectra of *$Nd^{3+}:La_{(1-x)}Ba_xF_{(3-x)}$ ($x=0.1$)*



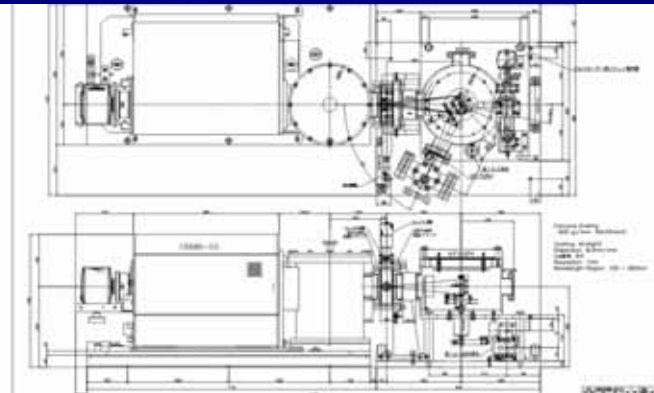
Excitation wavelength: 800 nm

Peak: 1053 nm

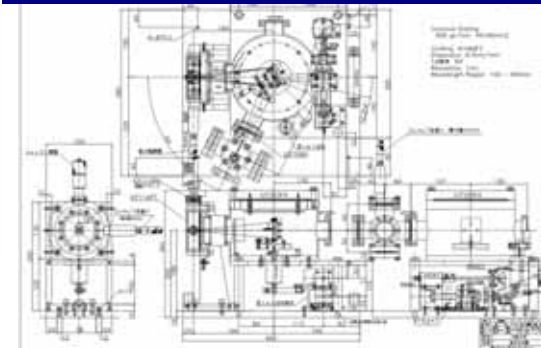
Experiment: Set – up for Evaluating VUV Fluorescence Lifetime of $\text{Nd}^{3+}:\text{La}_{(1-x)}\text{Ba}_x\text{F}_{(3-x)}$ ($x=0.1$)



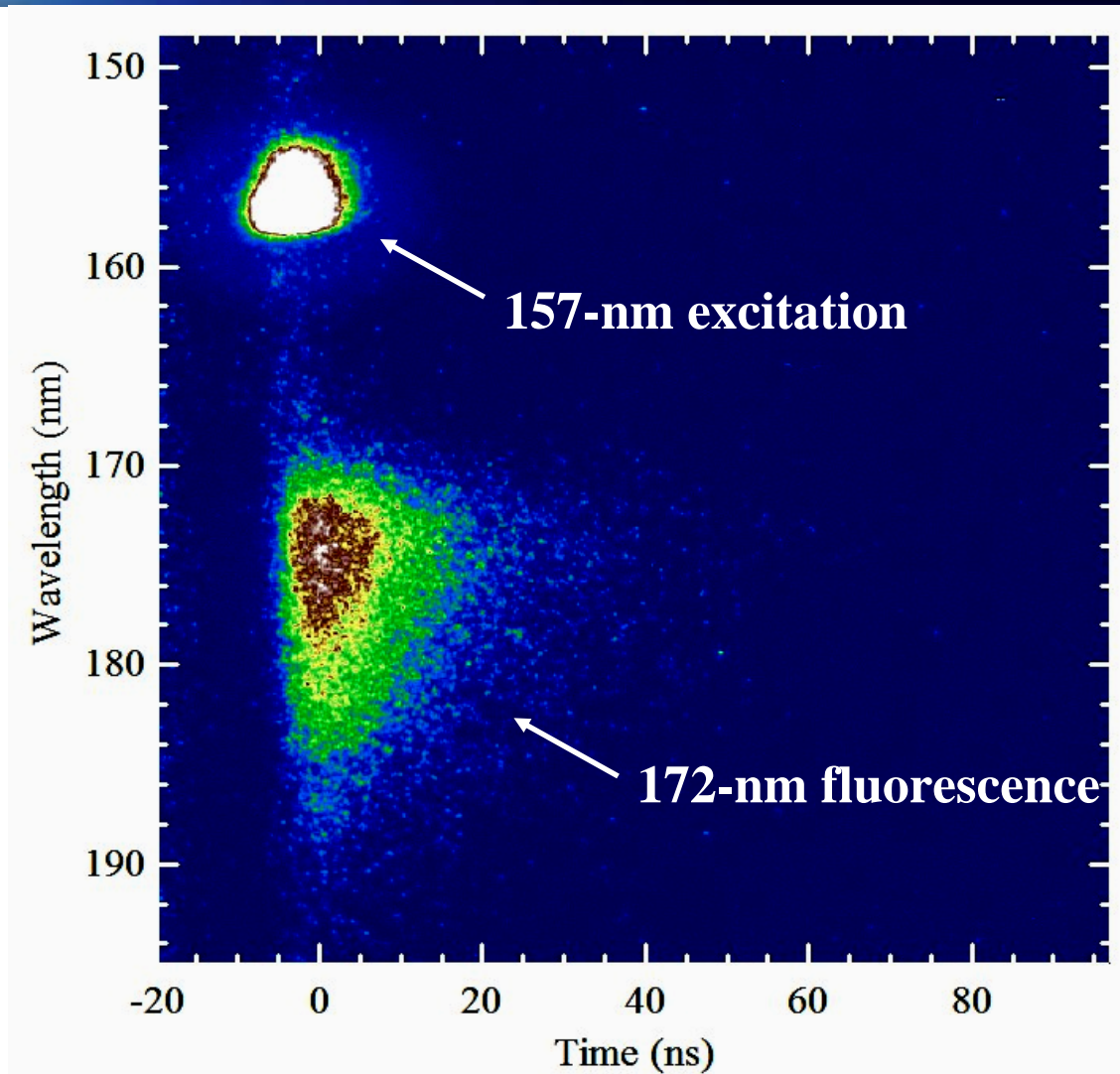
Specially designed streak camera system



Specially designed spectrometer

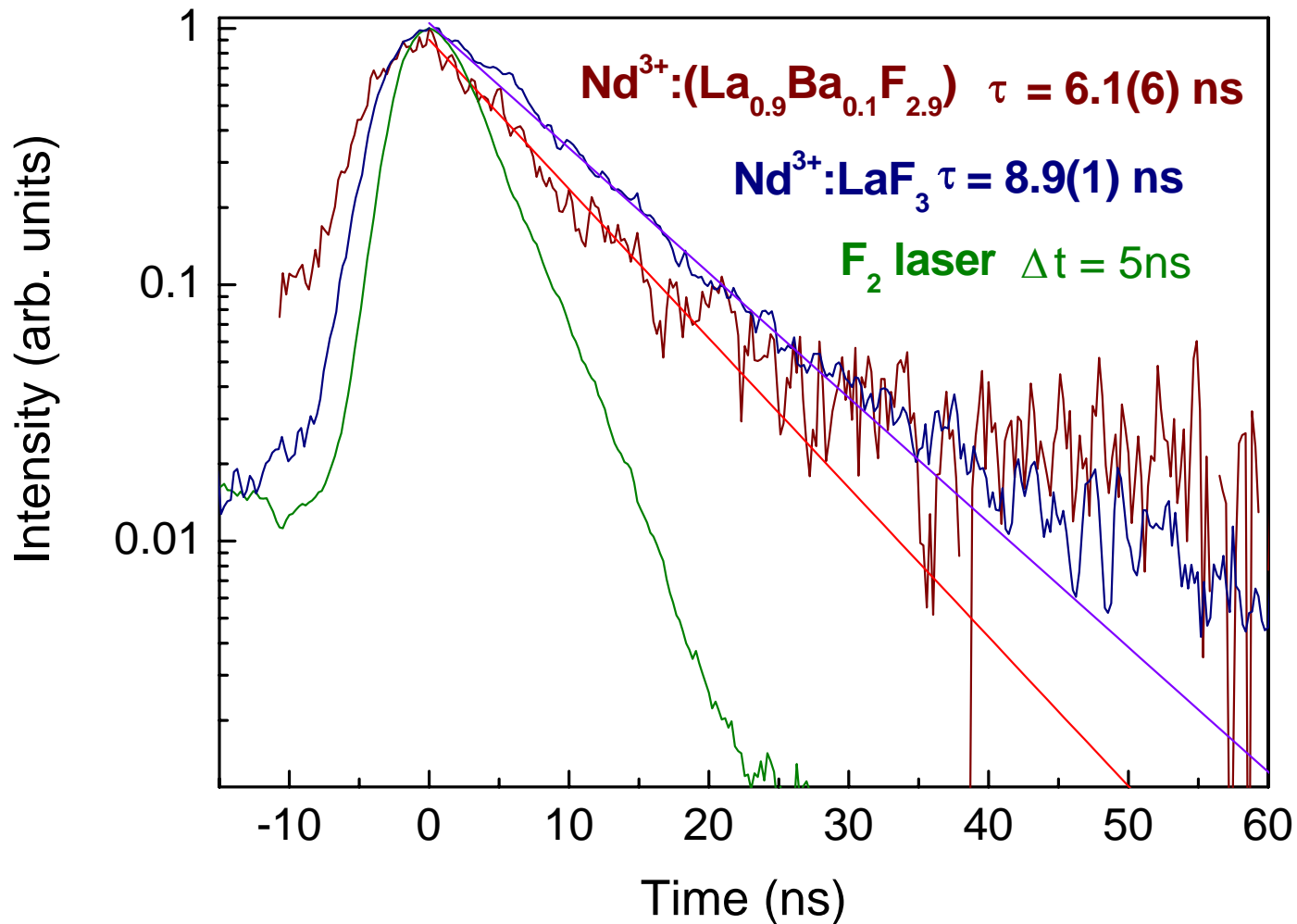


Experiment: Streak Camera Image of $\text{Nd}^{3+}:\text{LaF}_3$ Fluorescence



First VUV streak camera image

Experiment: $\text{Nd}^{3+}:(\text{La}_{1-x}\text{Ba}_x\text{F}_{3-x})$ ($x=0.1$) and $\text{Nd}^{3+}:\text{LaF}_3$ Temporal Profile



$\text{Nd}^{3+}:(\text{La}_{1-x}\text{Ba}_x)\text{F}_{3-x}$ ($x=0.1$) fluorescence decays faster

Summary

- $\text{Nd}^{3+}:(\text{La}_{1-x}, \text{Ba}_x)\text{F}_{3-x}$ ($x = 1$) single crystal is successfully grown using the micro-Pulling Down method.
- Undoped $\text{Nd}^{3+}:(\text{La}_{1-x}, \text{Ba}_x)\text{F}_{3-x}$ ($x = 1$) sample has short transmission edge at 160 nm compared to LaF_3 at 180 nm.
- Strong VUV fluorescence with peak located at 175 nm.
- Broad VUV fluorescence with FWHM of 12 nm compared to $\text{Nd}^{3+}:\text{LaF}_3$ with FWHM of 8 nm.

[1] M. Cadatal.et al, J. Appl. Phys., 46 (2007) L985 - L987.

[2] M. Cadatal,et al, J. Opt. Soc. Am. B in press